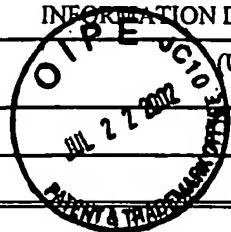


U.S. Department of Commerce, Patent and Trademark Office		Attorney Docket No.	10/085,951
		TT4274	10/085,867
INFORMATION DISCLOSURE STATEMENT BY APPLICANT		Applicant(s)	
(Use several sheets if necessary)		Russell C. Brown, Donald C. Likes, David A. Richardson, Yurong Shi, Jeffrey B. Toth	
		Filing Date	Group
		February 28, 2002	2122



## U.S. Patent Documents

*Examiner Initial	Document Number	Date	Name	Class	Subclass	Filing Date If Appropriate
HN	AA 6,334,122 B1	Dec. 25, 2001	Brown	707	2	Dec. 23, 1998
	AB 6,349,341 B1	Feb. 19, 2002	Likes	709	249	Jul. 30, 1998
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AG						
AH						
AI						
AJ						
AK						

## Foreign Patent Documents

						Translation	
	Document	Date	Country	Class	Subclass	Yes	No
AL						<input type="checkbox"/>	<input type="checkbox"/>
A						<input type="checkbox"/>	<input type="checkbox"/>
AN						<input type="checkbox"/>	<input type="checkbox"/>
AO						<input type="checkbox"/>	<input type="checkbox"/>
AP						<input type="checkbox"/>	<input type="checkbox"/>

## OTHER ART (Including Author, Title, Date, Pertinent Pages, Etc.)

AR	Doscher, David (Editor), "Computer Integrated Manufacturing (CIM) Framework Specification Version 2.0", Technology Transfer #93061697J-ENG, January 31, 1998 Sematech
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\*EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with your communication to applicant.